

Initial Information Data Sheet**Inventor Information**

Inventor One Given Name:	Hiroshi
Family Name:	YASUDA
Name Suffix:	
Postal Address Line One	c/o ADVANTEST CORPORATION
Postal Address Line Two	1-32-1 Asahi-cho, Nerima-ku
City:	Tokyo
State or Province:	Japan
Postal or Zip Code:	179-0071
Citizenship Country:	Japan
Inventor Two Given Name:	Shinichi
Family Name:	HAMAGUCHI
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Inventor Three Given Name:	Takeshi
Family Name:	HARAGUCHI
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Correspondence Information

Name Line One:	David L. Fehrman
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Application Information

Title Line One: SEMICONDUCTOR DEVICE
Title Line Two: MANUFACTURING SYSTEM
Title Line Three: AND ELECTRON BEAM
Title Line Four: EXPOSURE APPARATUS
Total Drawing Sheets: 8
Formal Drawings?: Yes
Application Type: Non-provisional
Docket Number: 514802001100

Representative Information

Representative Customer Number:



25224

PATENT TRADEMARK OFFICE

Continuity Information

This application is a:
> Application One:
Filing Date:

which is a:
>>Application Two:
Filing Date:

which is a:
>>>Application Three:
Filing Date:

Prior Foreign Applications

Foreign Application One: 2000-304245
Filing Date: October 3, 2000
Country: Japan
Priority Claimed: Yes

Assignee Information

Assignee: ADVANTEST CORPORATION